

METHOD OF FORMING A TRENCH FOR USE IN MANUFACTURING A SEMICONDUCTOR DEVICE

Application No. [NEW] - Attorney Docket No. SEC.1084

Inventors: Sung-Bae LEE et al.

FIG. 1A
(PRIOR ART)

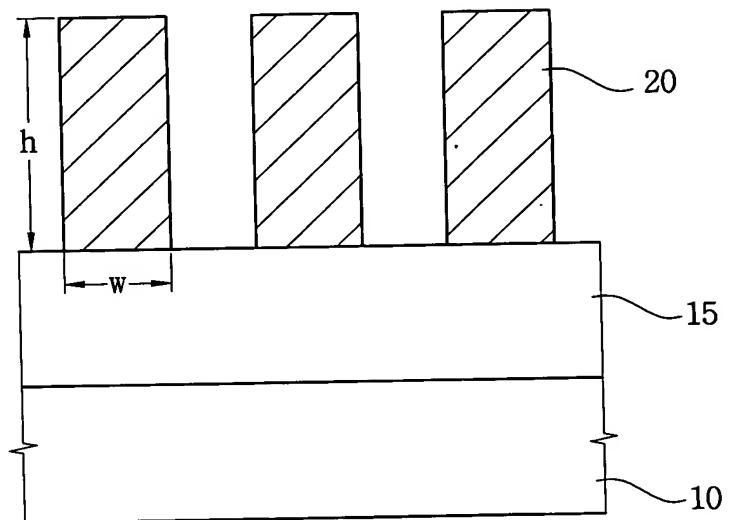


FIG. 1B
(PRIOR ART)

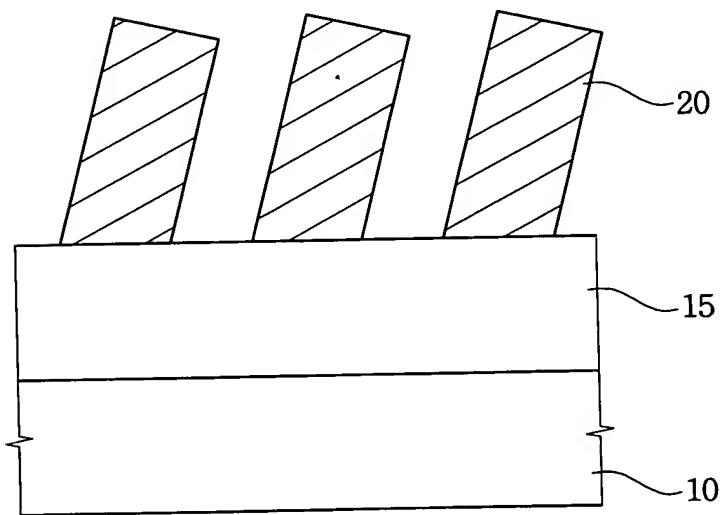


FIG. 2A

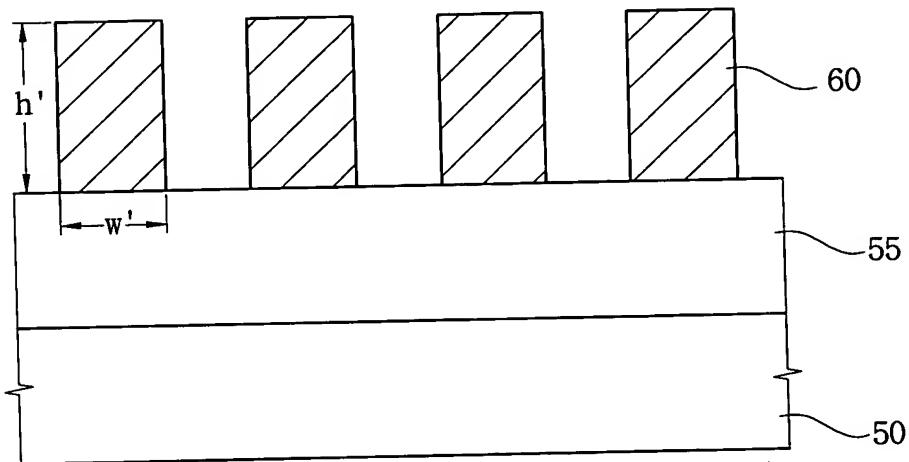


FIG. 2B

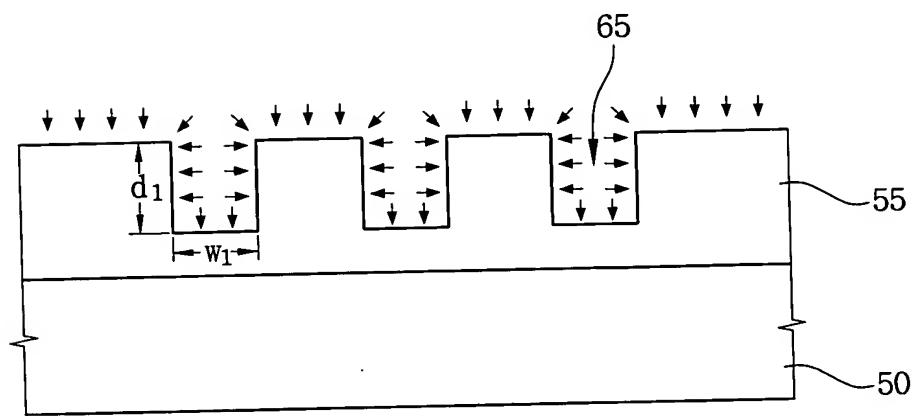
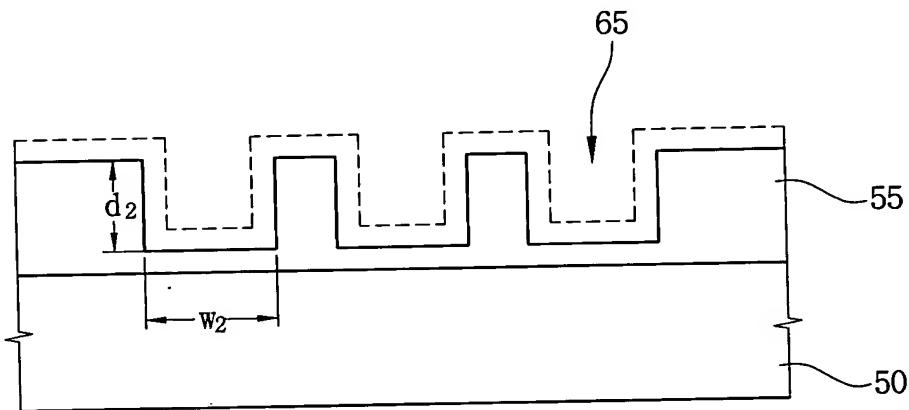


FIG. 2C



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FIG.3A

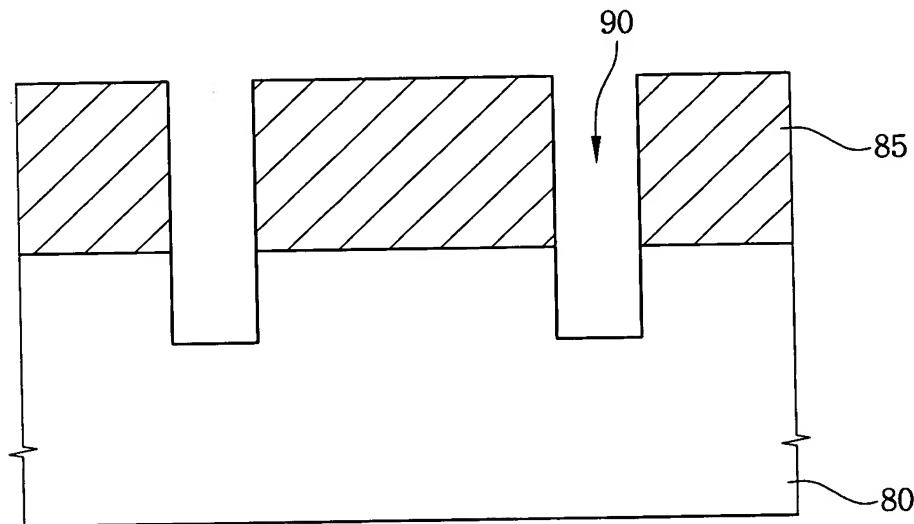


FIG.3B

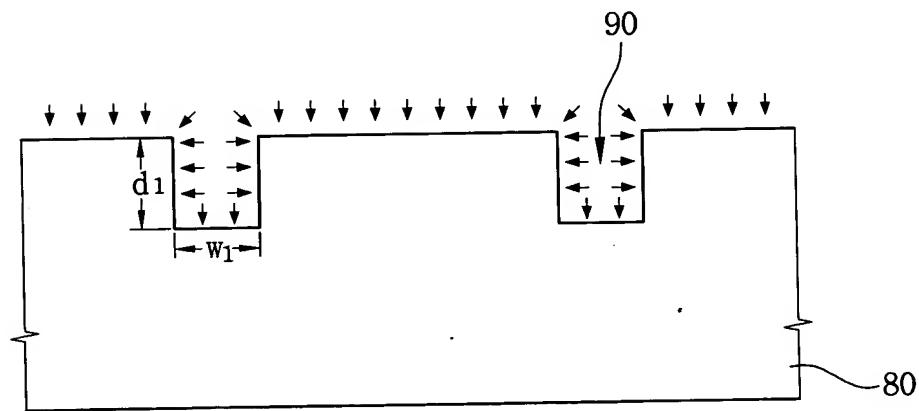


FIG.3C

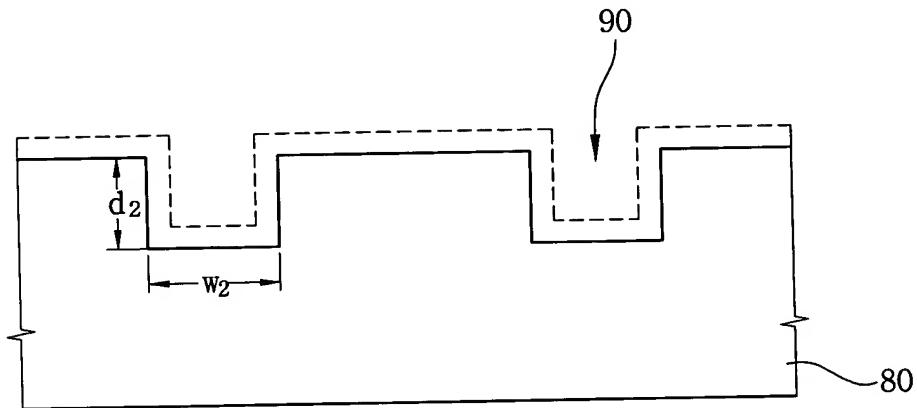
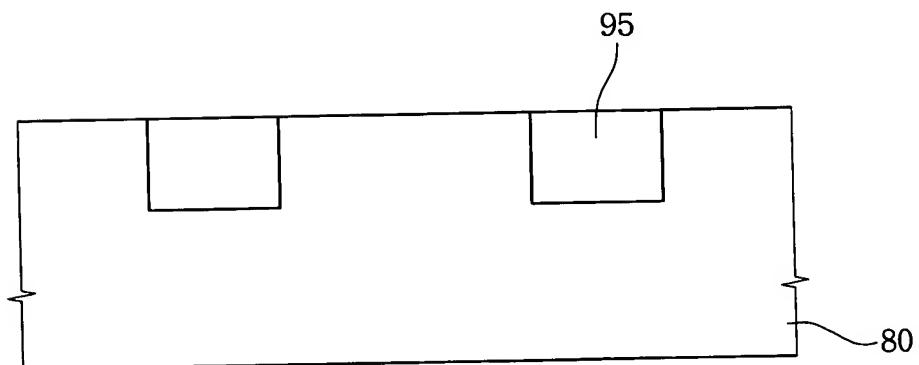


FIG.3D



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FIG.4A

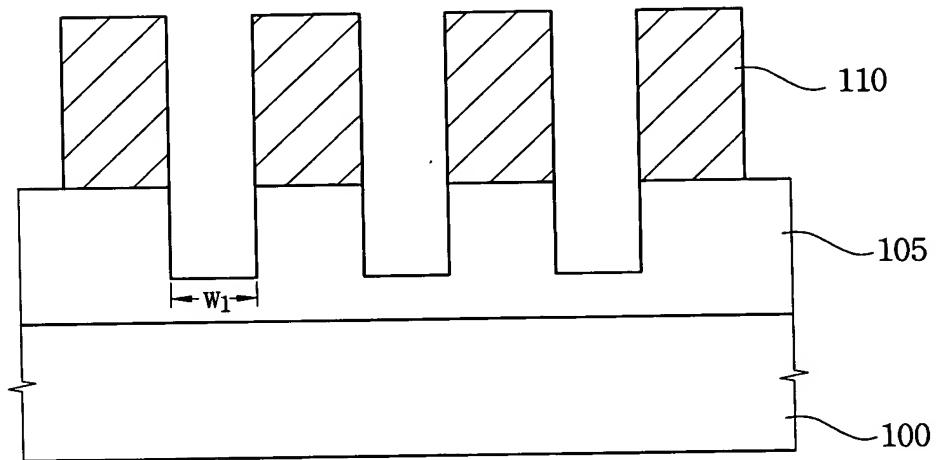


FIG.4B

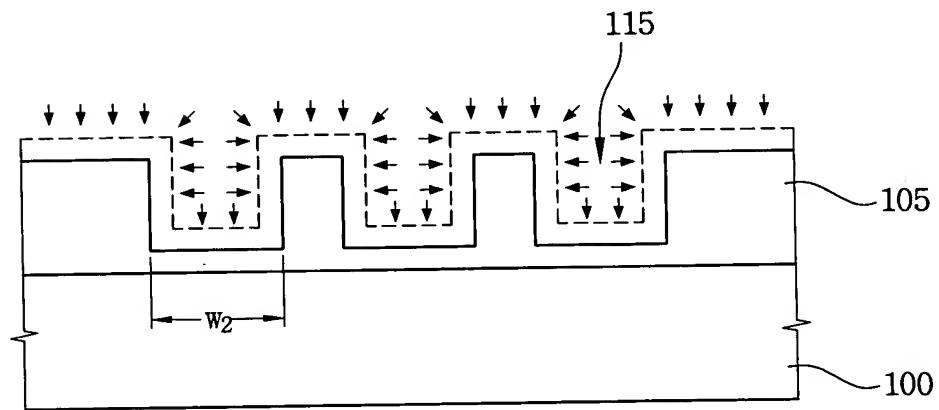


FIG. 4C

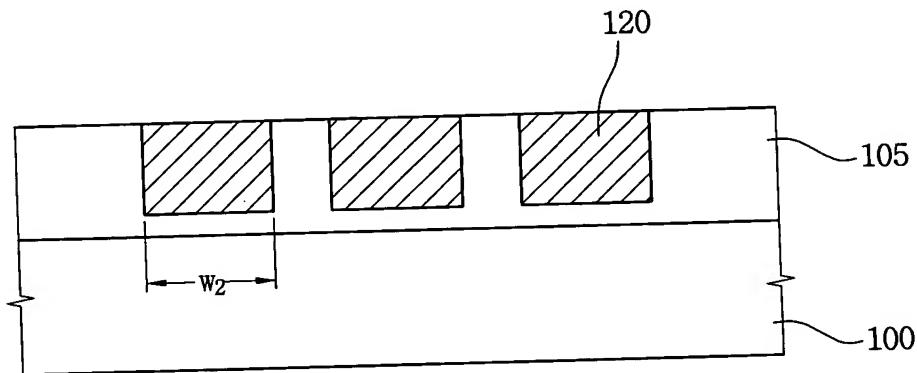


FIG.5A

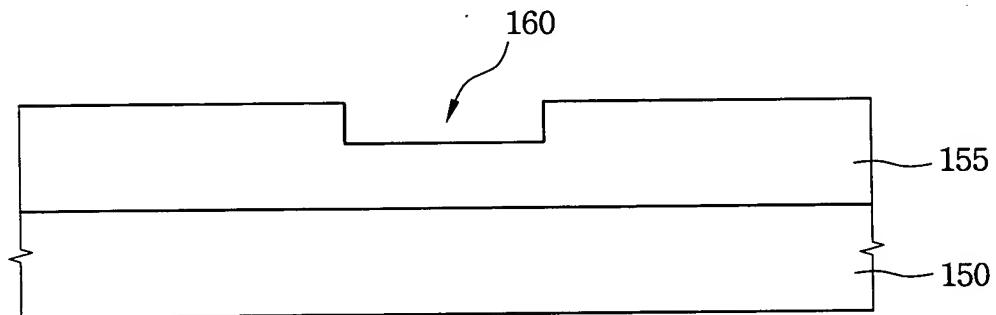


FIG.5B

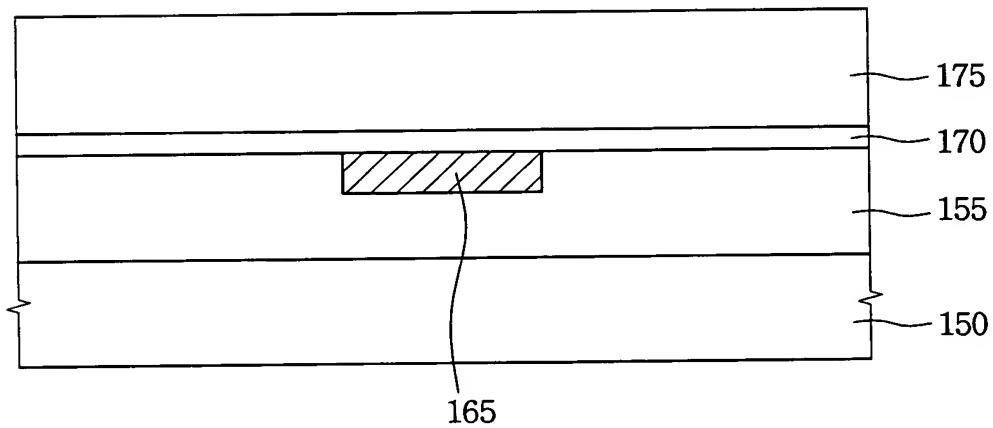


FIG.5C

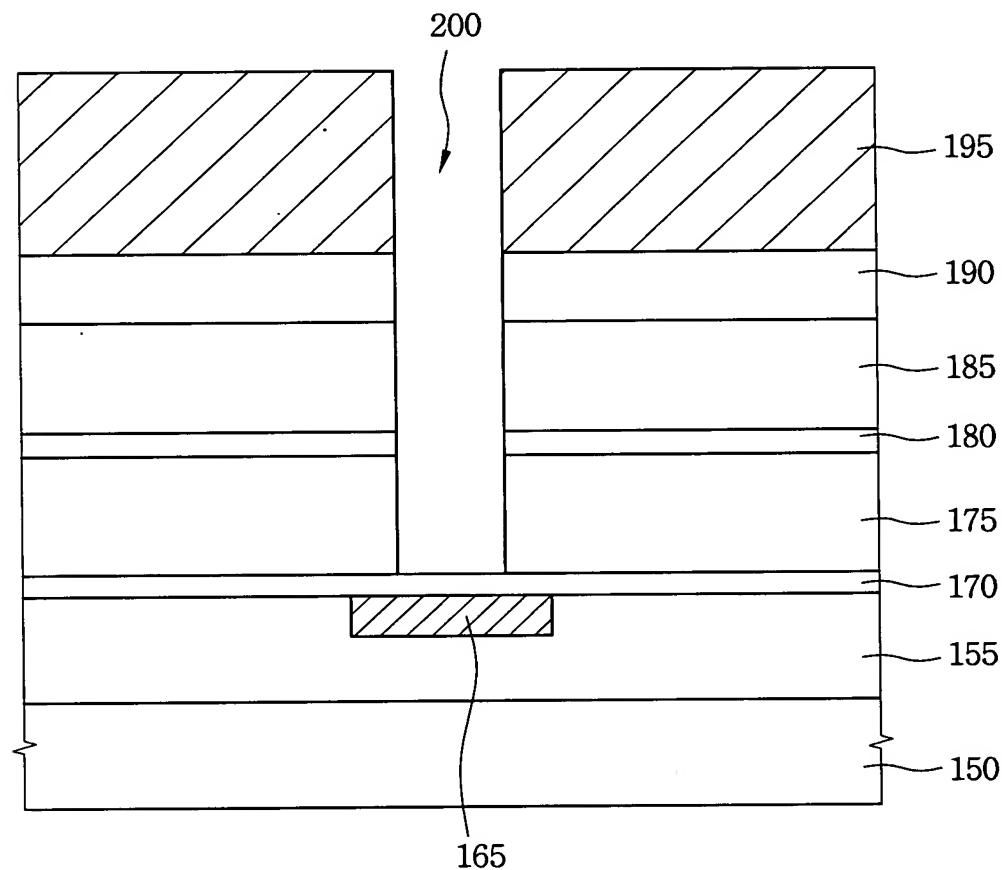


FIG.5D

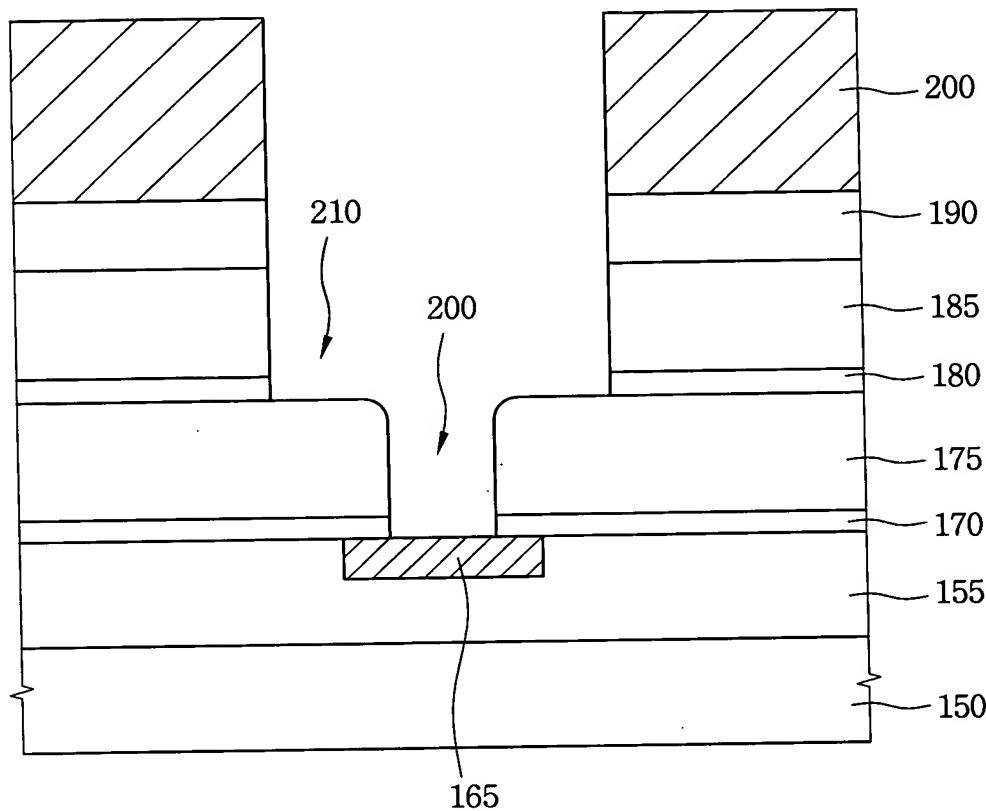


FIG.5E

